



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8728**
Norio KIMURA et al. : Docket No. 2000-1761A
Serial No. 09/742,386 : Group Art Unit 1763
Filed December 22, 2000 : Examiner Karla A. Moore
APPARATUS AND METHOD FOR : **Mail Stop: AMENDMENT**
PROCESSING SEMICONDUCTOR
SUBSTRATE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of
March 28, 2005.

The fee of \$120.00 is

- ☒ submitted herewith.
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
☐ Small entity status of this application is established by a Small Entity Status Assertion which
☐ is enclosed.
☐ has been previously submitted.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975


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NEP/krq
Washington, D.C. 20006-1021
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July 28, 2005

Respectfully submitted,

Norio KIMURA et al.

By 
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